

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<i>In re</i> Application of:	Hai Cong, et al.	:	Confirmation No.:	4993
Serial No.:	10/767,292	:	Art Unit:	2812
Filed:	1/29/2004	:	Examiner:	Mohsen Ahmadi
For:	A NOVEL METHOD TO CONTROL DUAL DAMASCENE TRENCH ETCH PROFILE AND TRENCH DEPTH UNIFORMITY	:		

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**SUPPLEMENTAL RESPONSE WITH
AMENDMENT AFTER FINAL REJECTION
UNDER 37 C.F.R. §1.116**

Sir:

The following Amendment and Remarks are submitted under 37 C.F.R. §1.116 in response to the Examiner's telephone call of March 6, 2007. After this introductory section, there are Amendments to the Claims and Remarks starting on a separate page.

Claims 33-35 have been deleted and claims 1, 9, and 20 have been amended.

The Remarks include a Summary of Telephonic Interview between the Examiner and Applicants' attorney.

Reconsideration of the rejections is respectfully requested.